

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Tomohei SUGIYAMA; Kyoichi KINOSHITA; Takashi YOSHIDA; Hidehiro KUDO; and  
Eiji KONO

Serial No.: TBA

Filed: Herewith

For: METHOD OF MANUFACTURING A LOW EXPANSION MATERIAL AND  
SEMICONDUCTOR DEVICE USING THE LOW EXPANSION MATERIAL

Group Art Unit: TBA

Examiner: TBA

**INFORMATION DISCLOSURE STATEMENT**

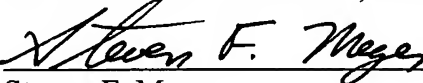
Mail Stop Patent Application  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Pursuant to Rule 56, applicant hereby calls the attention of the Patent Office to the references listed on the attached Form PTO 1449. Copy(ies) of these references ☒ are attached ☐ were filed in related application U.S. Serial No(s) \_\_\_\_\_, filed \_\_\_\_\_, respectively.

- ☐ This document is being filed within three (3) months of the filing date of the application
- ☐ Please charge the \$180 fee to Deposit Account No. 13-4500, Order No. \_\_\_\_\_.
- ☒ This document is being concurrently filed with the above-identified application
- ☐ This document is being concurrently filed with an Request for Continued Examination (RCE)
- ☐ This document is being filed prior to a first Office Action
- ☐ This document is accompanied by a Search Report/Communication cited in a corresponding PCT or foreign counterpart application.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required for this Information Disclosure Statement, or credit any overpayment to Deposit Account No. 13-4500, Order No. 5000-5118. A DUPLICATE COPY OF THIS SHEET IS ATTACHED.

Respectfully submitted,  
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Dated: July 23, 2003

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